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| <b>INFORMATION DISCLOSURE<br/>STATEMENT BY APPLICANT</b><br>(Not for submission under 37 CFR 1.99) | Application Number     |  | 10784979       |  |
|  | Filing Date            |  | 2004-02-25     |  |
|  | First Named Inventor   |  | YACH, David P. |  |
|  | Art Unit               |  | 2166           |  |
|  | Examiner Name          |  | LIN, Shew Fen  |  |
|  | Attorney Docket Number |  | P1645US00      |  |

**U.S. PATENTS**

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|-------------------|---------|--------------------|------------------------|------------------|---|--|
|                   | 1       | 20030131023        | A1                     | 2003-27-10       | Bassett et al.                                  |  |

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| Examiner Signature | /Shew Fen Lin/ | Date Considered | 01/20/2010 |
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